



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of )  
)  
Kazuo MAEDA ) Examiner: Quach  
)  
Serial No.: 09/519,599 ) Art Unit: 2814  
)  
Filed: March 6, 2000 )  
)  
For: METHOD AND APPARATUS FOR )  
FORMING AN INTERLAYER )  
INSULATING FILM AND )  
SEMICONDUCTOR DEVICE )

PETITION FOR EXTENSION OF TIME UNDER 37 CFR 1.136

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the time period for filing a response to the office action of April 23, 2003, initially set to expire July 23, 2002, be extended one month up to and including August 23, 2003. The requisite \$110.00 fee for the requested extension is herewith attached.

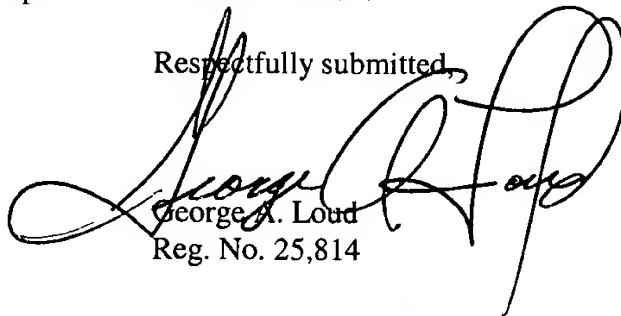
Any additional fees may be charged to Deposit Account No. 12-2174.

08/15/2003 CNGUYEN 00000056 09519599

01 FC:1251

110.00 OP

Respectfully submitted,

  
George A. Loud  
Reg. No. 25,814

Date: August 14, 2003

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